

Docket No.: K-284

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Jae Wook LEE

Serial No. New U.S. Patent Application

Filed: May 16, 2001

For: SHADOW MASK ASSEMBLY



AUTHORIZATION TO TREAT A REPLY AS INCORPORATING  
AN EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a)(3)

Assistant Commissioner for Patents  
Washington, D. C. 20231

Sir:

The U.S. Patent and Trademark Office is hereby authorized to treat any concurrent or future reply that requires a petition for an extension of time under this paragraph for its timely submission, as incorporating a petition for extension of time for the appropriate length of time under 37 C.F.R. 1.136(a)(3). The U.S. Patent and Trademark Office is hereby authorized to charge all required extension of time fees to our Deposit Account No. 16-0607, if such fees are not otherwise provided for in such reply. A duplicate copy of this sheet is enclosed.

Respectfully submitted,  
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